



Attorney Docket No.: P-8503-US

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants:

ZAIT, Eitan et al.

Examiner:

Not yet assigned

Serial No.:

10/564,972

Group Art Unit:

Not yet assigned

Filed:

January 18, 2006

Title:

METHOD FOR CORRECTING CRITICAL DIMENSION VARIATIONS IN

PHOTOMASKS

Mail Stop Amendment Commissioner for Patents P. O. Box 1450 Alexandria, VA 22313-1450

Sir:

INFORMATION DISCLOSURE STATEMENT

Pursuant to 37 C.F.R. §§1.56, 1.97 and 1.98, this Information Disclosure Statement includes Form PTO/SB/08:

1.	listing documents including patents, publications and other information for consideration by
	the Examiner, however, since the subject application was filed after June 30, 2003, copies of
	United States patents and/or United States patent application publications are not included in
	this information disclosure statement; and/or
2.	listing documents including patents, publications and other information that have been
	previously cited or submitted to the Patent Office in prior application U.S. Serial No,
	filed which is properly identified and relied on for an earlier effective filing date under
	35 U.S.C. 120 for consideration by the Examiner; however, in accordance with 37 C.F.R.
	1.98(d), copies of such documents are not included in this information disclosure statement;
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3. 🗵	listing documents including patents, publications, and other information for consideration by
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4.	listing other information for the Examiner's consideration which was cited in a
	communication from a foreign patent office in a counterpart foreign application, a copy of
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APPLICANTS:

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SERIAL NO.: FILED:

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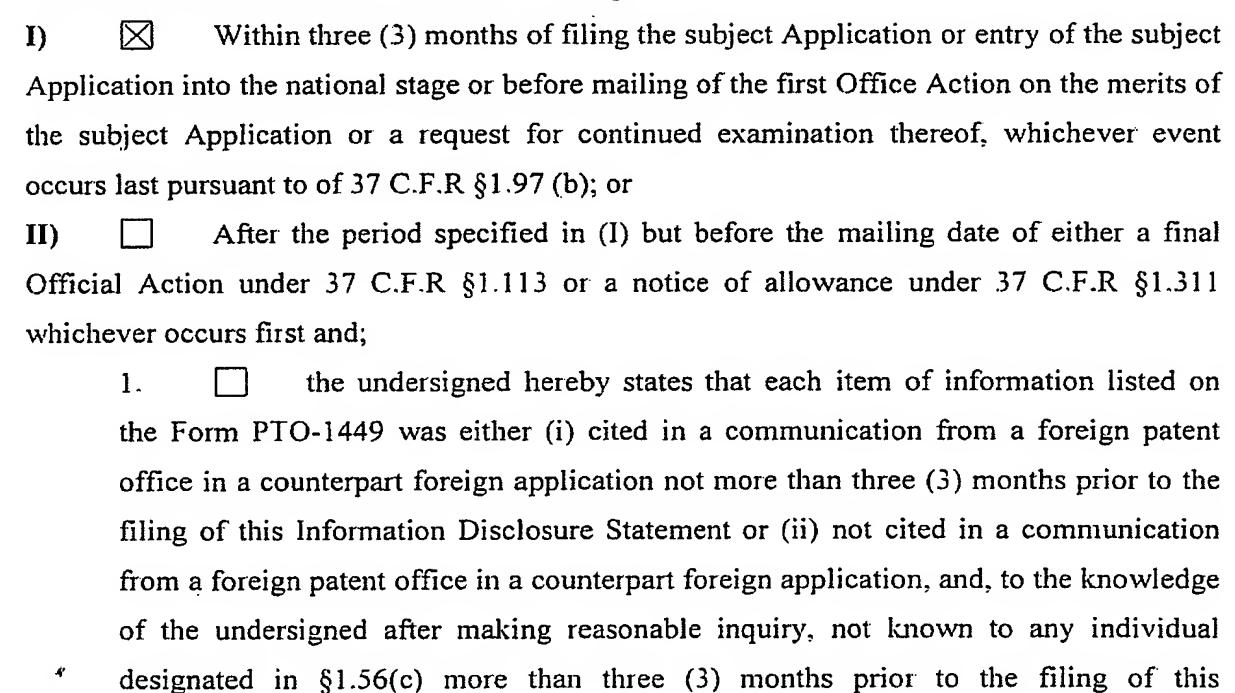
The information herein cited is only in fulfillment of Applicant(s) duty of candor in disclosing all information brought to Applicant(s) attention. This submission does not represent that a search has been made or that no better art exists and does not constitute an admission that each or all of the listed documents are material or constitute "prior art". If it should be determined that any of the listed documents do not constitute "prior art" under United States law, Applicant(s) reserve the right to present to the office the relevant facts and law regarding the appropriate status of such documents.

Applicant(s) further reserve(s) the right to take appropriate action to establish the patentability of the disclosed invention over the listed documents, should one or more of the documents be applied against the claims of the present application.

In accordance with MPEP Sections 609 and 707.05(b), it is requested that each and every document cited (including any cited in applicant's specification which is not repeated on the attached Form PTO-1449) be given thorough consideration and that it be cited of record in the prosecution history of the present application by initialing on Form PTO-1449. Such initialing is requested even if the Examiner does not consider it to be prior art for any reason, or even if the Examiner does not believe that the guidelines for citation have been fully complied with. This is requested so that each document becomes listed on the face of the patent issuing on the present application and is evidence that the Examiner has considered the document.

This Information Disclosure Statement is being filed:

information disclosure statement; or



APPLICANTS: SERIAL NO.:

III)

ZAIT, Eitan et al.

FILED:

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and

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2. the undersigned hereby authorizes the Patent Office to charge the fee in the amount of \$180.00 under 37 C.F.R §1.17 (p) to Deposit Account 50-3355. After the period in (I) and (II) but before the payment of the issue fee and, The undersigned hereby states: 1. that each item of information cited on the form PTO-1449 was a) cited in a communication from a foreign Patent Office in a counterpart foreign application not more than three (3) months prior to the filing of this Information Disclosure Statement; or that no items of information contained in Form PTO-1449 was b) cited in a communication from a foreign patent office in a counterpart foreign application, and to the knowledge of the undersigned after making reasonable inquiry, no item of information contained in this Information Disclosure Statement was known to any individual designated in 37 C.F.R. § 1.56(c) more

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Except for issue fees payable under 37 C.F.R. §1.18, the Commissioner is hereby authorized by this paper to charge any additional fees during the entire pendency of this application including fees due under 37 C.F.R. §§1.16 and 1.17 which may be required, including any required extension of time fees, or credit any overpayment to Deposit Account No. 50-3355.

Respectfully submitted,

Attorney/Agent for Applicants

Registration No. 52,388

Dated: February 21, 2006

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PTO/SB/08b (07-05)

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Substi	Substitute for form 1449B/PTO			Complete if Known		
				Application Number	10/564,972	
INFORMATION DISCLOSURE STATEMENT BY APPLICANT (use as many sheets as necessary)				Filing Date	January 18, 2006	
				First Named Inventor	ZAIT, Eitan	
				Art Unit	Not yet assigned	
				Examiner Name	Not yet assigned	
Sheet	1	of	1	Attorney Docket Number	P-8503-US	

		NON PATENT LITERATURE DOCUMENTS	
Examiner Initials*	Cite No.1	Include name of the author (in CAPITAL LETTERS), title of the article (where appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T²
	Α	Jong Rak Park et al, "Improvement of Shot Uniformity on a Wafer by Controlling Backside Transmittance	
		Distribution of a Photomask", Optical Microlithography, Proceedings of SPIE, Vol. 5040. 2003, pp. 553-560	
	В	Alfred Kwok-Kit Wong. "Resolution Enhancement Techniques in Optical Lithography", SPIE Press 2001,	
		Chapter 1 3 4, pp 18-23	
Evamina:		Date	10 10 10 10 10 10 10 10 10 10 10 10 10 1
Examiner Signature		Considered	

The collection of information is required by 37 CFR 1 97 and 1.98. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to process) an application. Confidentiality is governed by 35 U S C 122 and 37 CFR 1 14. This collection is estimated to take 2 hours to complete, including gathering, preparing, and submitting the completed application form to the USPTO. Time will vary depending upon the individual case. Any comments on the amount of time you require to complete this form and/or suggestions for reducing this burden, should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, U.S. Department of Commerce, P.O. Box 1450. Alexandria, VA 22313-1450. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

^{*} EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered include copy of this form with next communication to applicant.

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Applicant's unique citation designation number (optional)

Applicant is to place a check mark here if English language Translation is attached